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1742

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Notice of Allowance Mailed: September 20, 2004

Issue Fee Paid: December 13, 2004

Application No.: 09/875,789

Filing Date: June 6, 2001

Applicant: Akira ARAI

Group Art Unit: 1742

Examiner: John P. Sheehan

Title: MAGNETIC POWDER, MANUFACTURING METHOD
OF MAGNETIC POWDER AND BONDED MAGNETS

Attorney Docket: 9319A-000228

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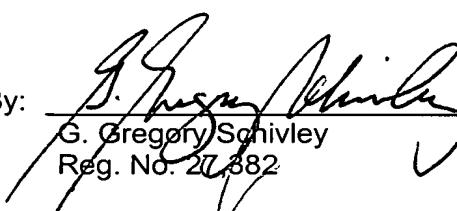
Sir:

Please make the information set forth on the enclosed Form 1449 of record in this file.

The listed documents were cited in a search report for a corresponding European patent application. However, Applicant makes no admission that the disclosures in these documents affect the presumption of validity for the claims in this issued patent.

Respectfully submitted,

Dated: May 6, 2005

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Sheet 1 of 1

ATTORNEY DOCKET NO.	SERIAL No.
9319A-000228	09/875,789
APPLICANT	
Akira ARAI	
FILING DATE	GROUP
June 6, 2001	1742

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	RECEIVED	Class/ Subclass	(If appropriate) Filing Date
1.					DEC 13 2006		

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FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes	No
1.		0 302 395	2/8/1989	EPO		N/A	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.		Communication from European Patent Office re: counterpart application.

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Examiner:

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